

Notice of References Cited	Application/Control No. 10/612,542		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner David H. Malzahn		Art Unit 2193	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,781,589	08-2004	Macy et al.	345/537
*	B	US-6,542,541	04-2003	Luna et al.	375/240.01
*	C	US-6,247,112	06-2001	Seki, Takahito	712/42
*	D	US-6,195,741	02-2001	Asato, Akira	712/24
*	E	US-5,857,114	01-1999	Kim, Sun-gi	710/22
*	F	US-5,740,394	04-1998	Minemura et al.	5/411
*	G	US-5,572,334	11-1996	Tanaka, Nobuyuki	382/246
*	H	US-2002/0144027	10-2002	Schmisseur, Mark A.	710/22
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.